

Electronic Acknowledgement Receipt

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Application Number:	10605108
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Title of Invention:	METHOD FOR REDUCED N+ DIFFUSION IN STRAINED SI ON SIGE SUBSTRATE
First Named Inventor:	Dureseti Chidambarao
Correspondence Address:	Andrew M. Calderon Greenblum and Bernstein P.L.C. 1950 Roland Clarke Place - Reston VA 20191 US 7037161191 -
Filer:	Andrew Michael Calderon/Ramon Linsangan
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment After Final	p27374_amend.pdf	318214	no	12

Warnings:**Information:****Total Files Size (in bytes):**

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.